

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:)	CONFIRMATION NO.: 8170
)	
Hiroyuki MATSUURA)	
)	
U.S. Serial No.: 10/563,208)	Group Art Unit: 3753
)	
Filed: January 3, 2006)	Examiner: Kevin L. Lee
For: PRESSURE REDUCTION PROCESS DEVICE, PRESSURE REDUCTION PROCESS METHOD, AND PRESSURE REGULATION VALUE		

RESPONSE AS SUBMISSION UNDER 37 C.F.R. § 1.114

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A reply to the Office Action of December 21, 2010 was due by March 21, 2011. Submitted herewith, together with the requisite fee, is a Petition for extending the time of reply up to and including June 21, 2011. Both this paper and the Petition are accompanied by a Request for Continued Examination (RCE) and its requisite fee. Please accept all of these papers as timely filed.